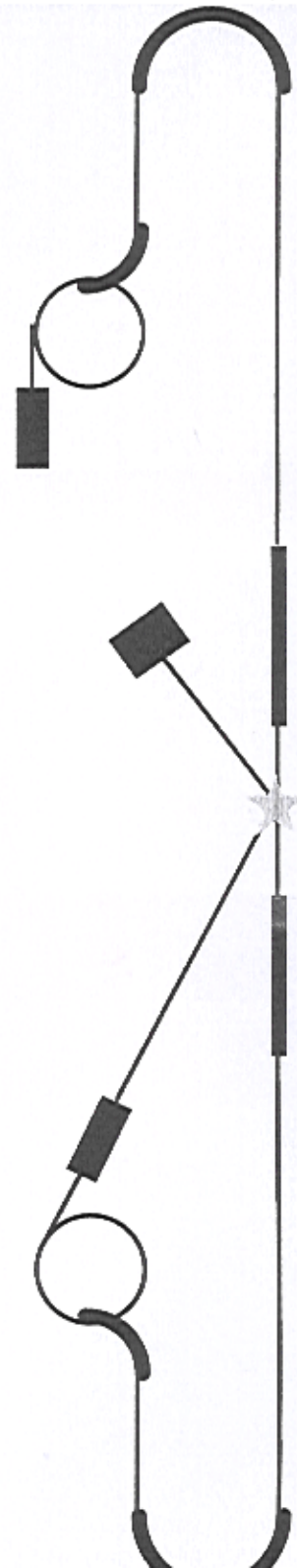


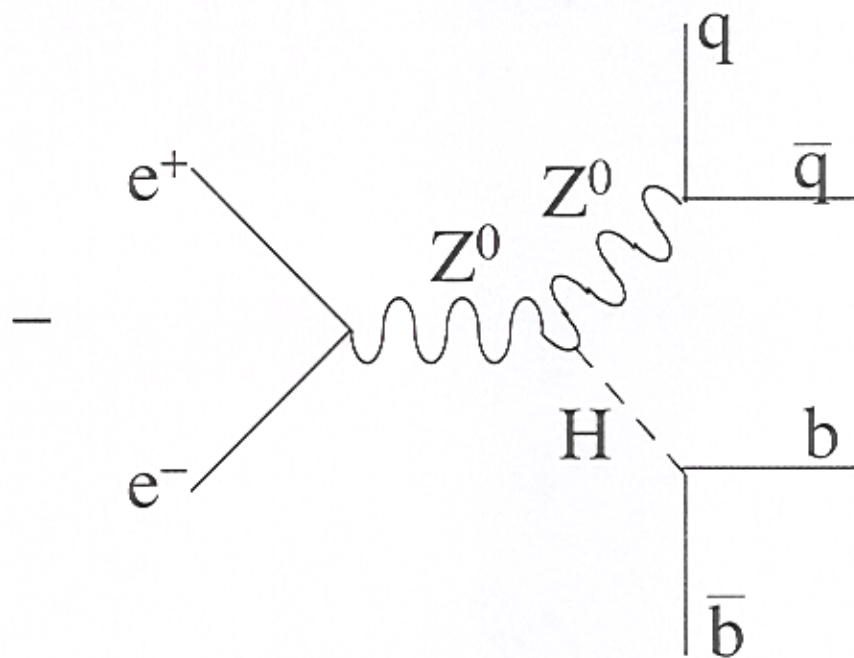
A TESLA compatible vertex detector design

- ◆ Introduction
- ◆ Detector design
- ◆ Progress with realization
- ◆ Performance
- ◆ Problems at TESLA...
- ◆ ...and their solution
- ◆ Summary



Introduction

- ◆ Develop vertex detector and associated analysis techniques which allow high purity and efficiency beauty and charm identification.
- ◆ Physics motivation:

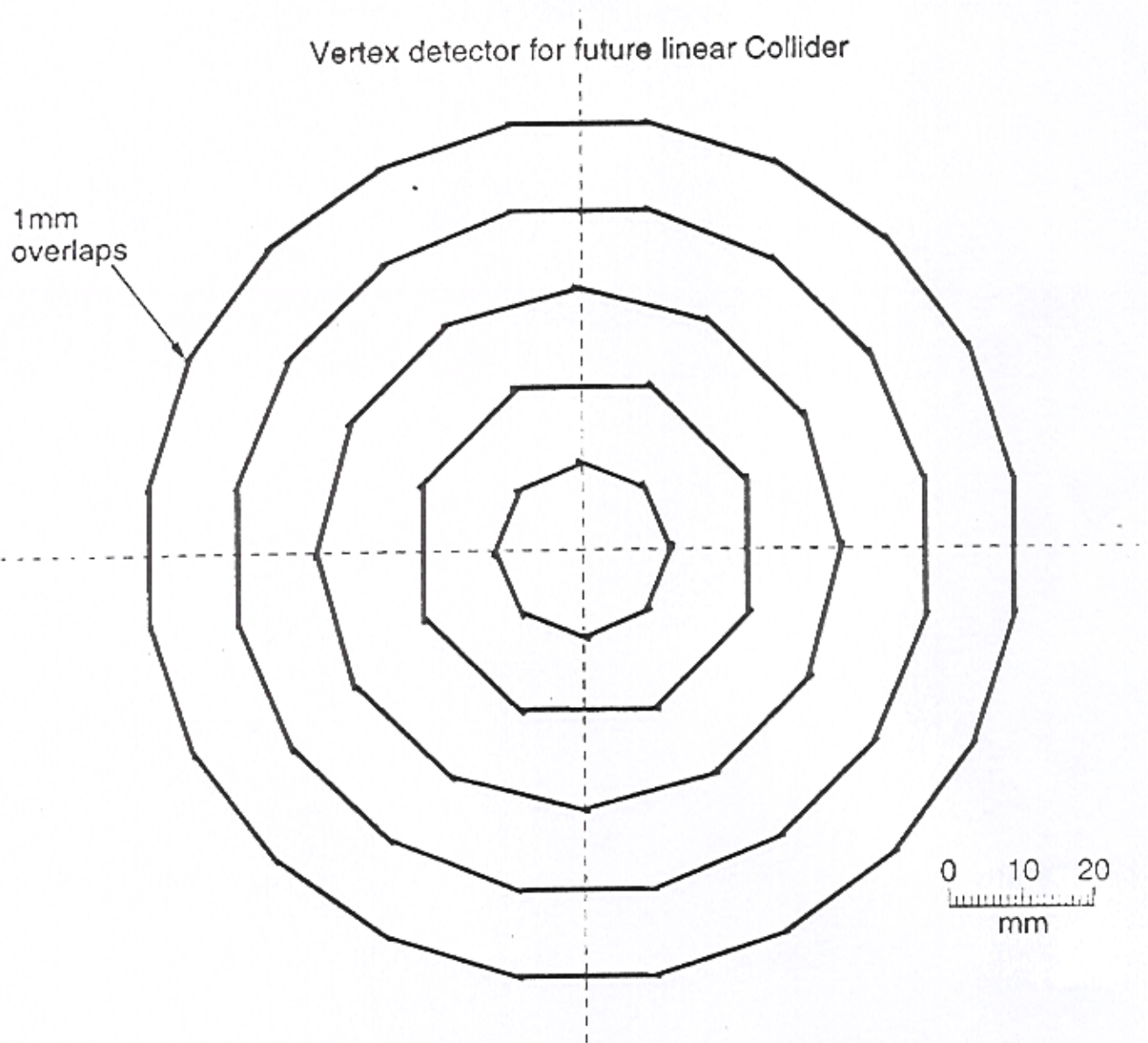


$$\frac{\text{BR}(H^0 \rightarrow c\bar{c})}{\text{BR}(H^0 \rightarrow b\bar{b})}$$

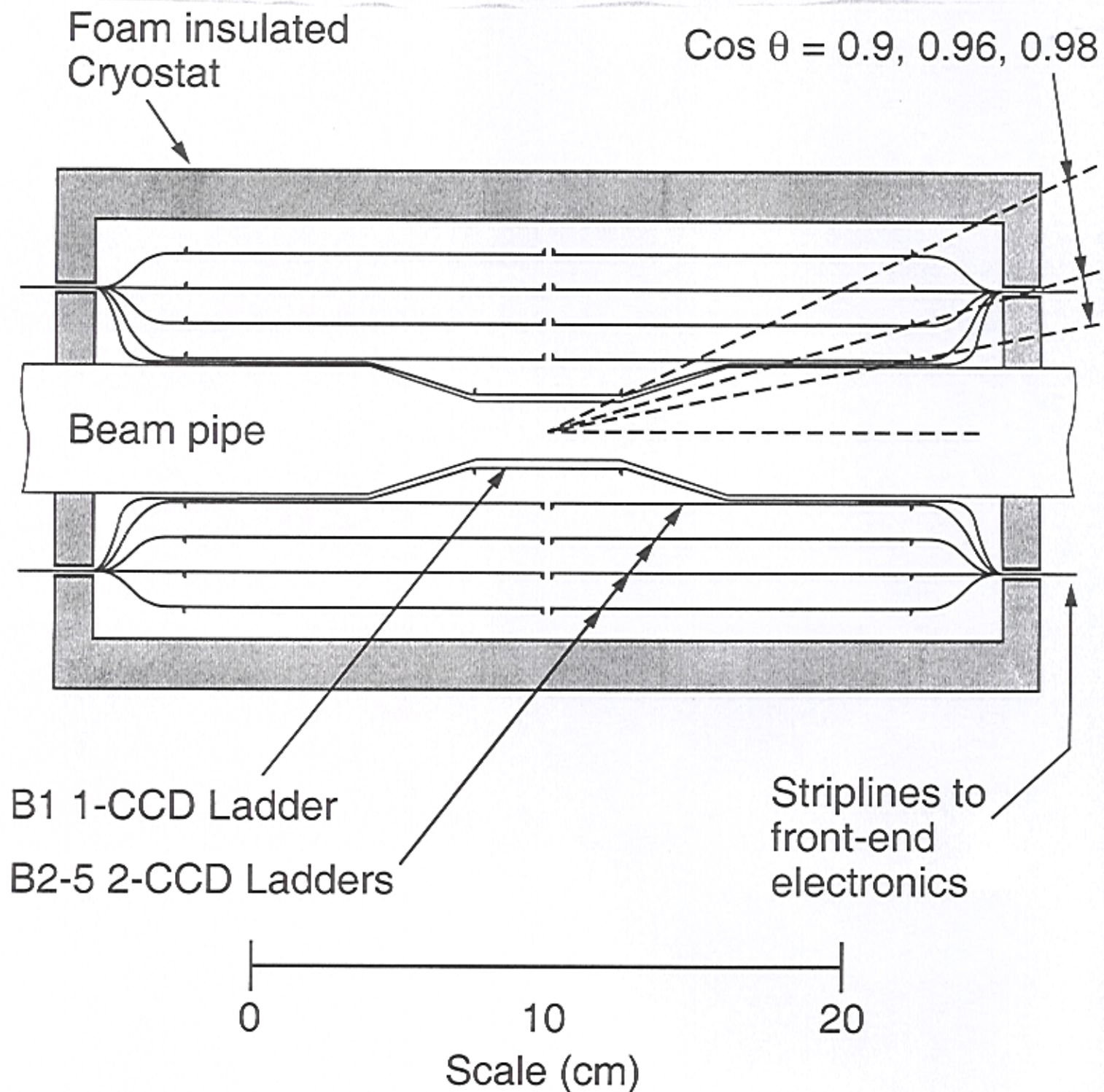
Flavour tagging, goals for detector

- ◆ Layer 1 thickness $\sim 0.12\% X_0$.
- ◆ Layer 1 radius ~ 12 mm.
- ◆ $\sigma_{\text{pnt}} \sim 3.5$ μm .
- ◆ These all appear feasible with a CCD based vertex detector.
- ◆ Proposed design...

CCD based vertex detector end view

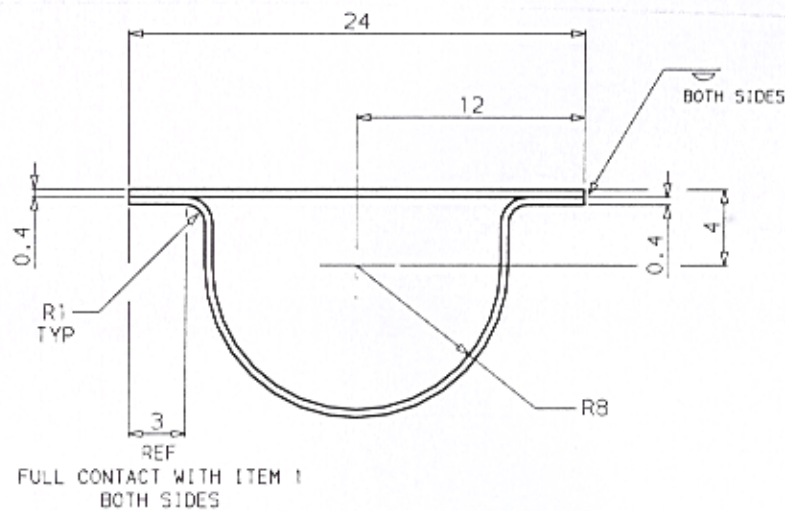


CCD based vertex detector side view

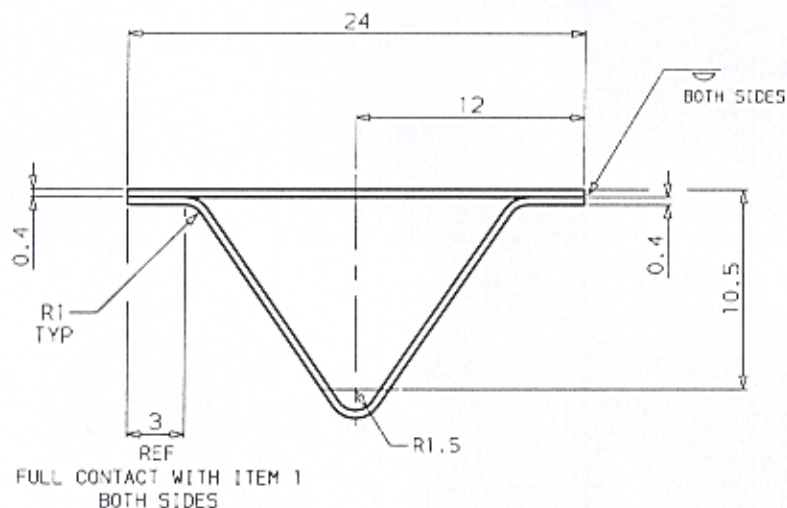


Material budget and mechanical support

◆ Beryllium Ω beam...

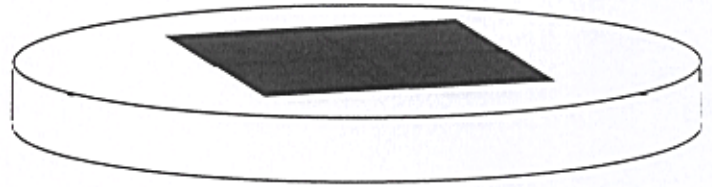


◆ ...or V beam.

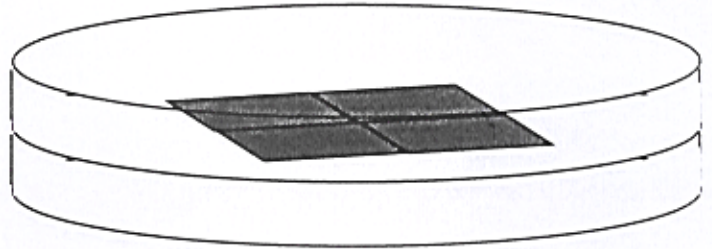


Thin CCDs

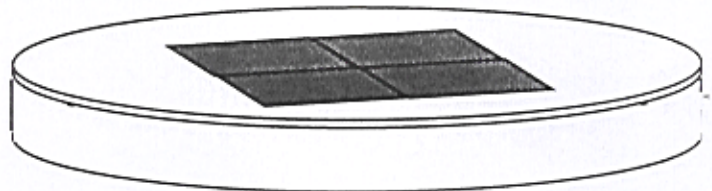
- ◆ Processed wafer.



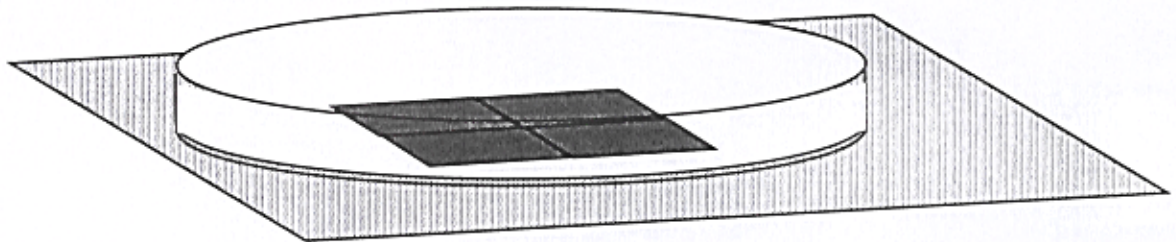
- ◆ Face to face with dummy wafer.



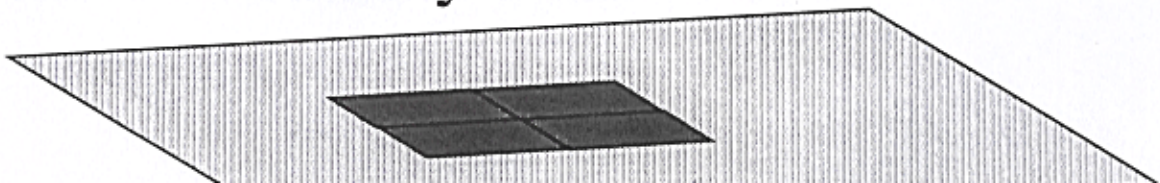
- ◆ Lap and etch sandwich.



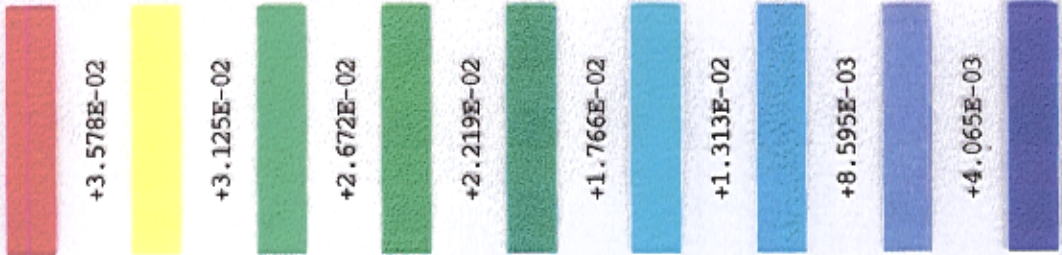
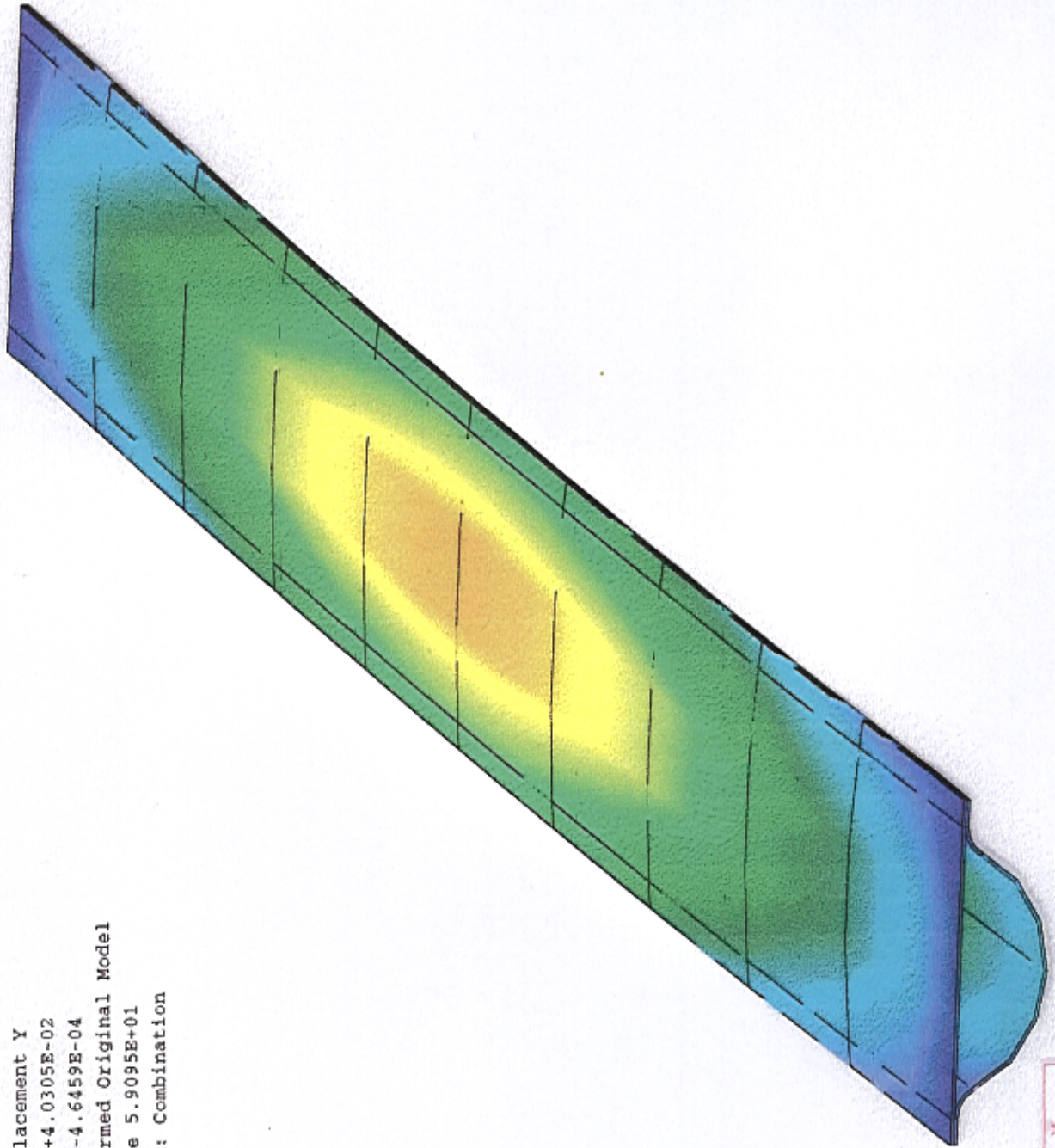
- ◆ Attach to ladder.



- ◆ Remove dummy wafer



Displacement Y
Max +4.0305E-02
Min -4.6459E-04
Deformed Original Model
Scale 5.9095E+01
Load: Combination



Material budget

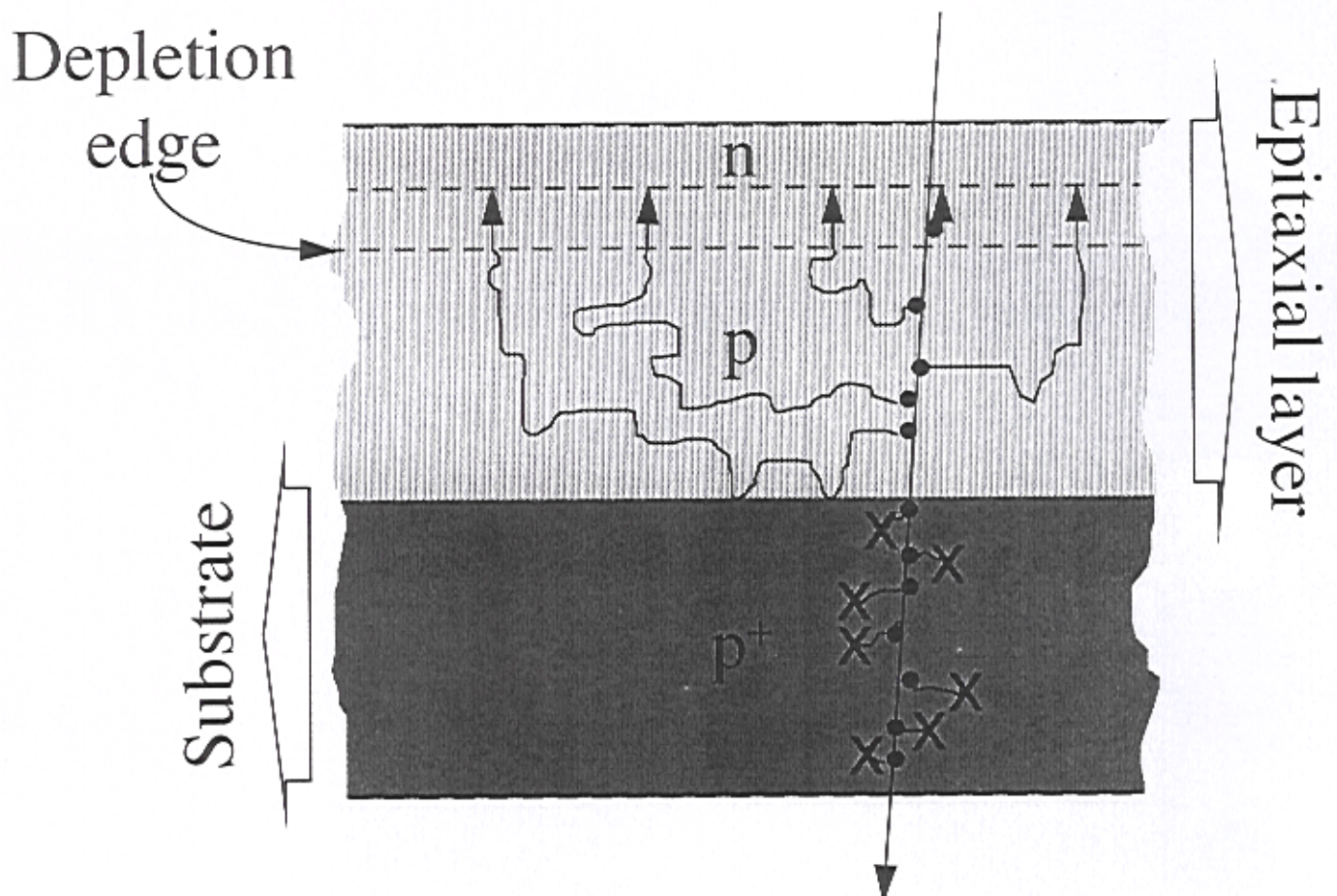
- ◆ Currently foreseen:

Item	Thickness ($\%X_0$)
250 μm Be beampipe	0.07
Adhesive	0.02
20 μm silicon	0.02
Total layer 1	0.11

- ◆ Reduction of beampipe thickness possible?
- ◆ Consider putting first layer CCD in vacuum?

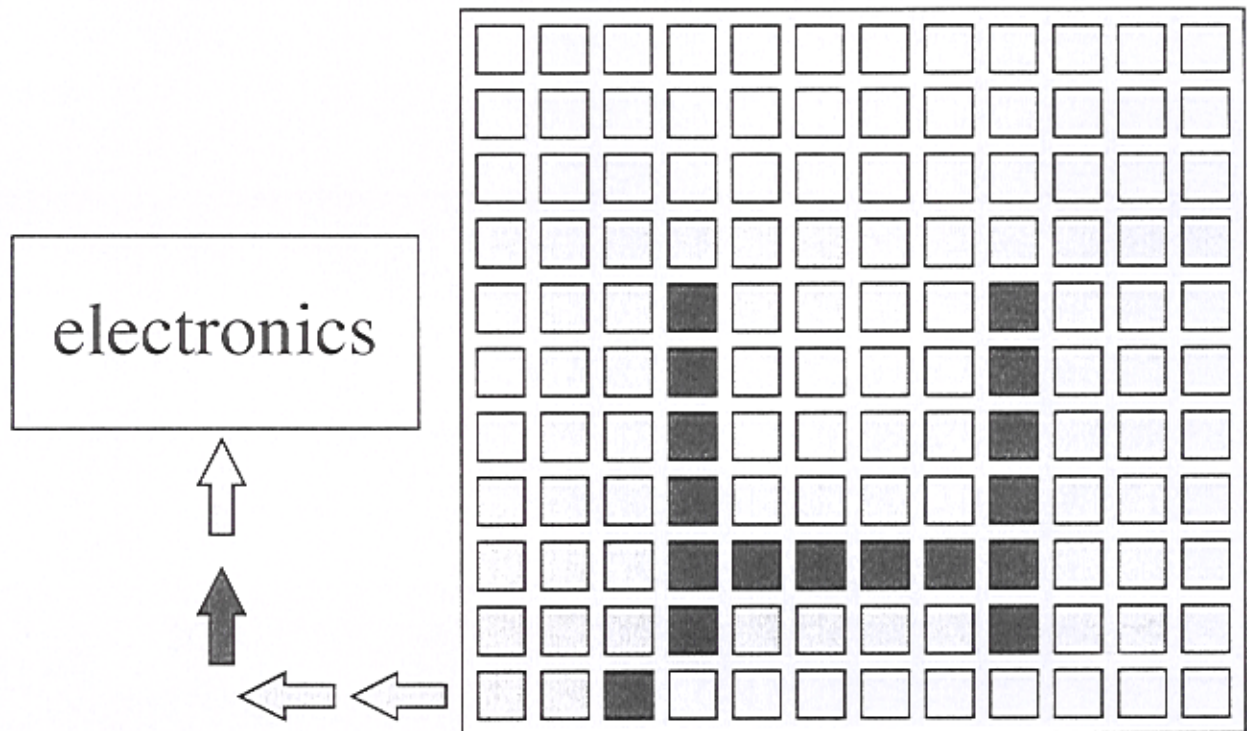
Point resolution

- ◆ $\sigma_{\text{pnt}} \sim 3.5 \mu\text{m}$ achievable with $20 \times 20 \mu\text{m}^2$ pixels with modest improvements to S:N for CCDs.
 - Thicken epitaxial layer.
 - Improve readout circuit.



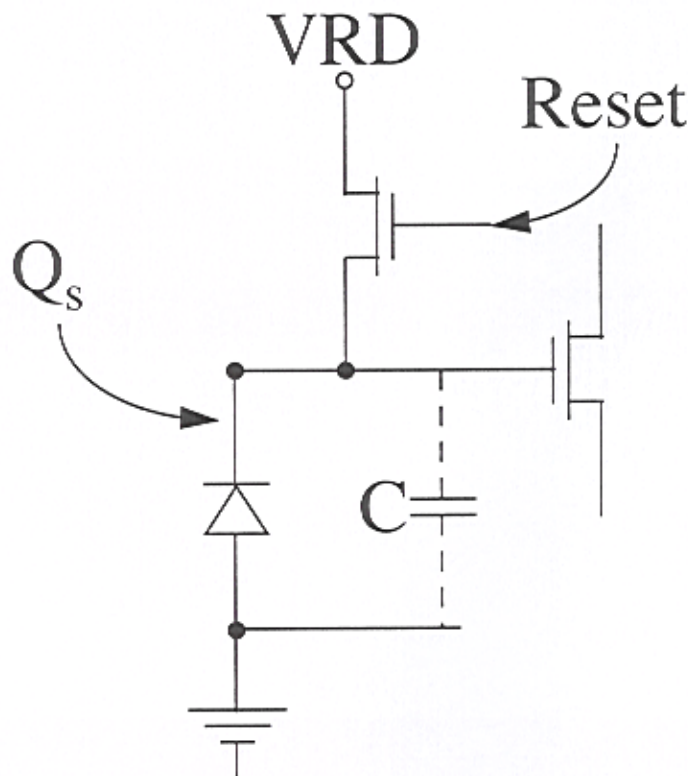
CCD readout

- ◆ Schematic diagram of CCD readout scheme:

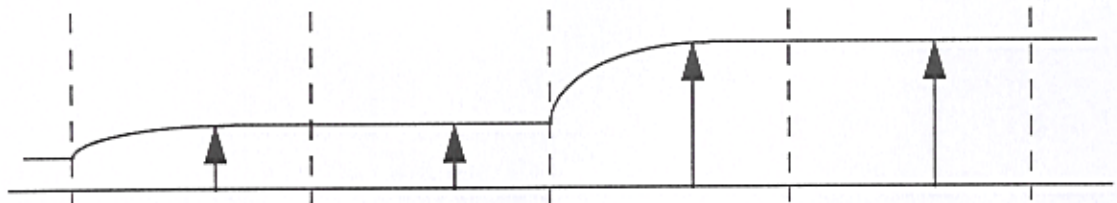


Improving S:N

- ◆ Current readout circuit:

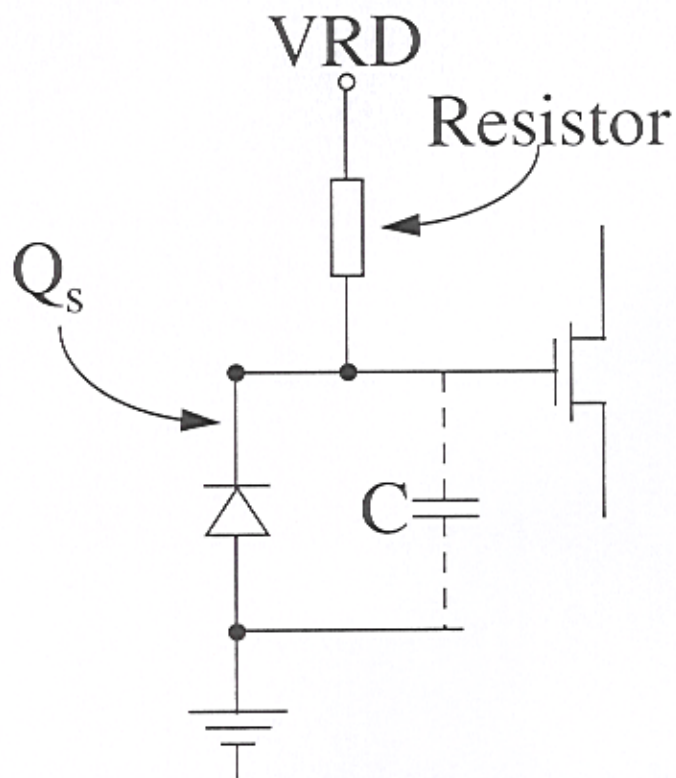


- ◆ Reset once per row, so readout of row looks like:

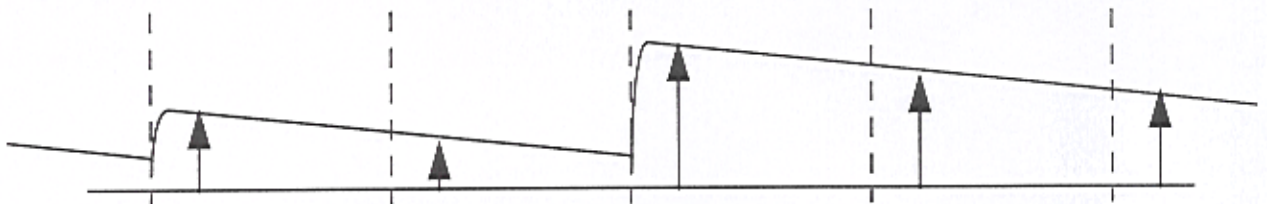


Improving S:N

- ◆ Replace reset transistor with resistor



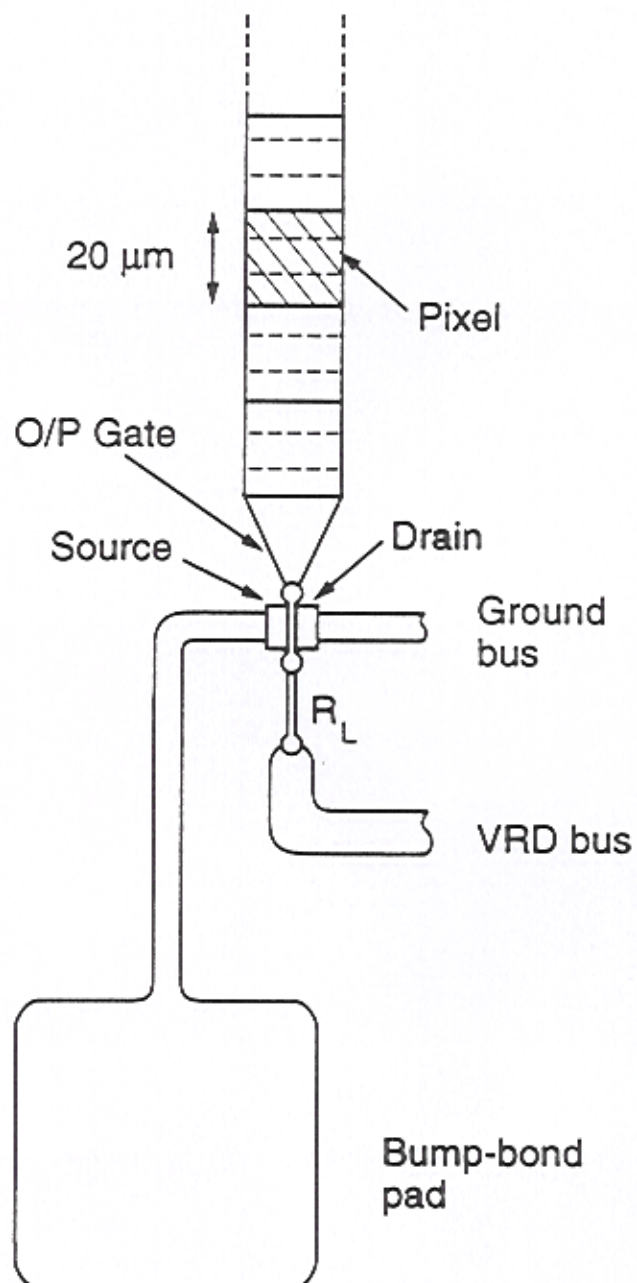
- ◆ Readout then looks like:



- ◆ Issues:

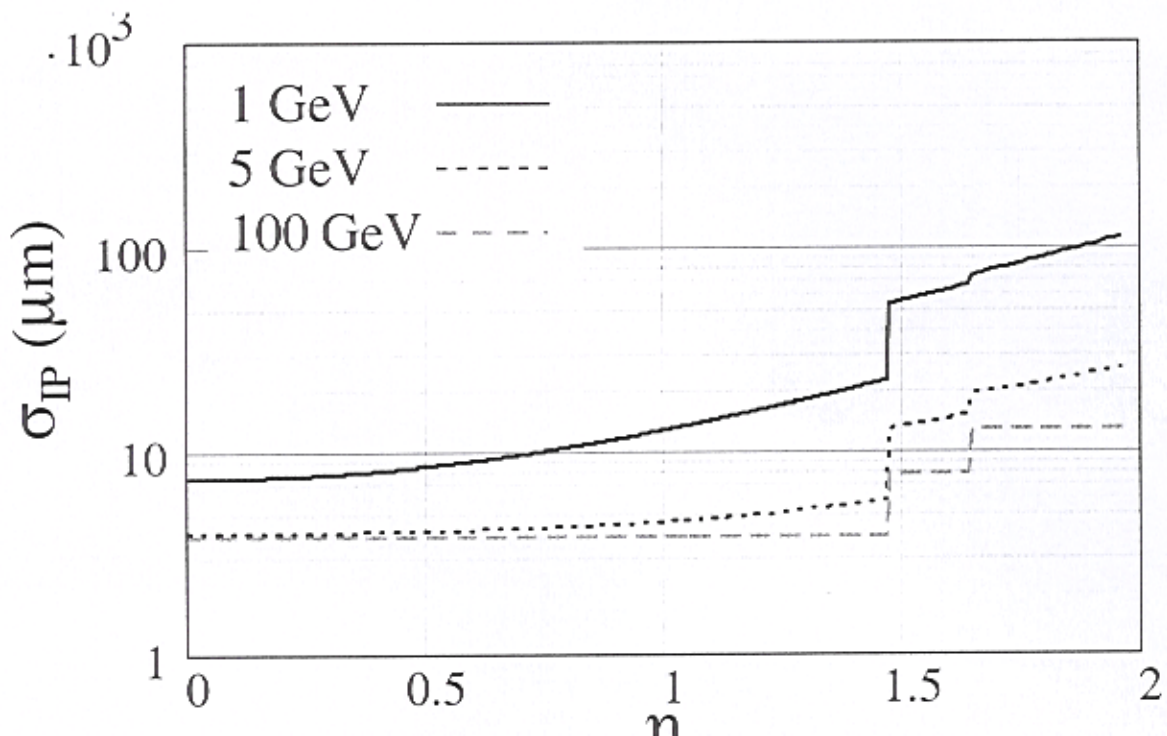
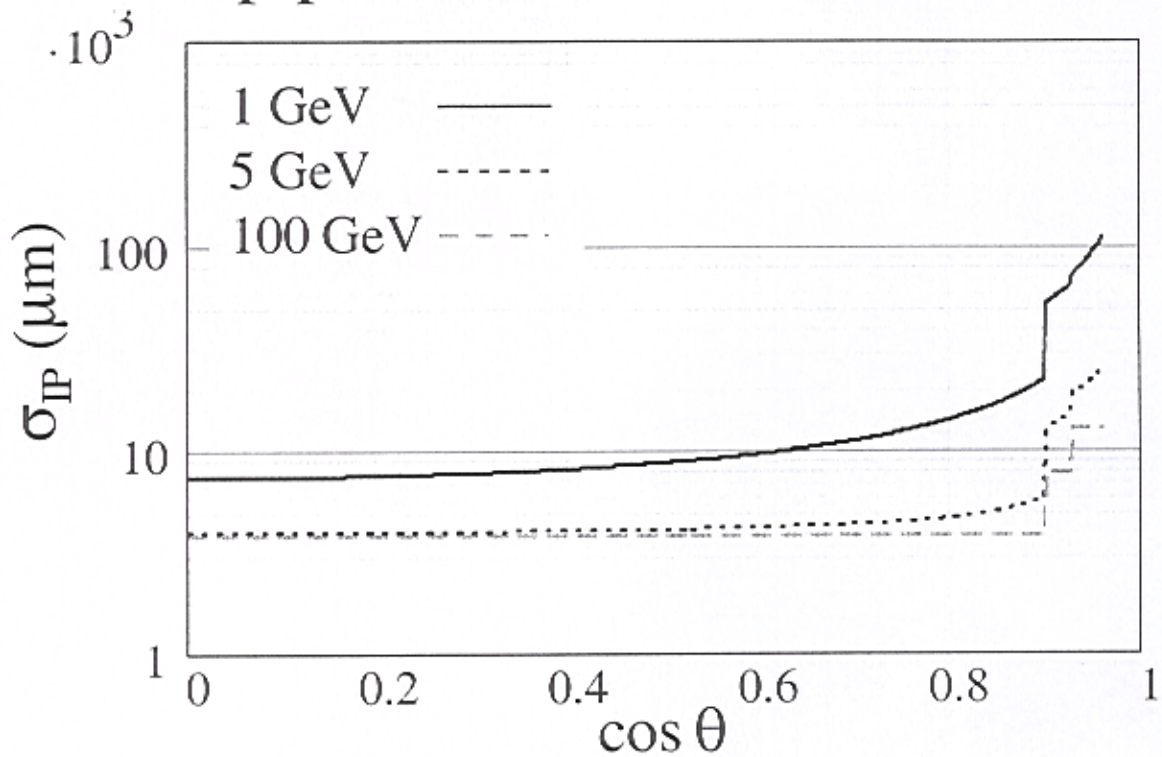
- How to construct resistor?
- Achievable noise?

Possible output circuit design



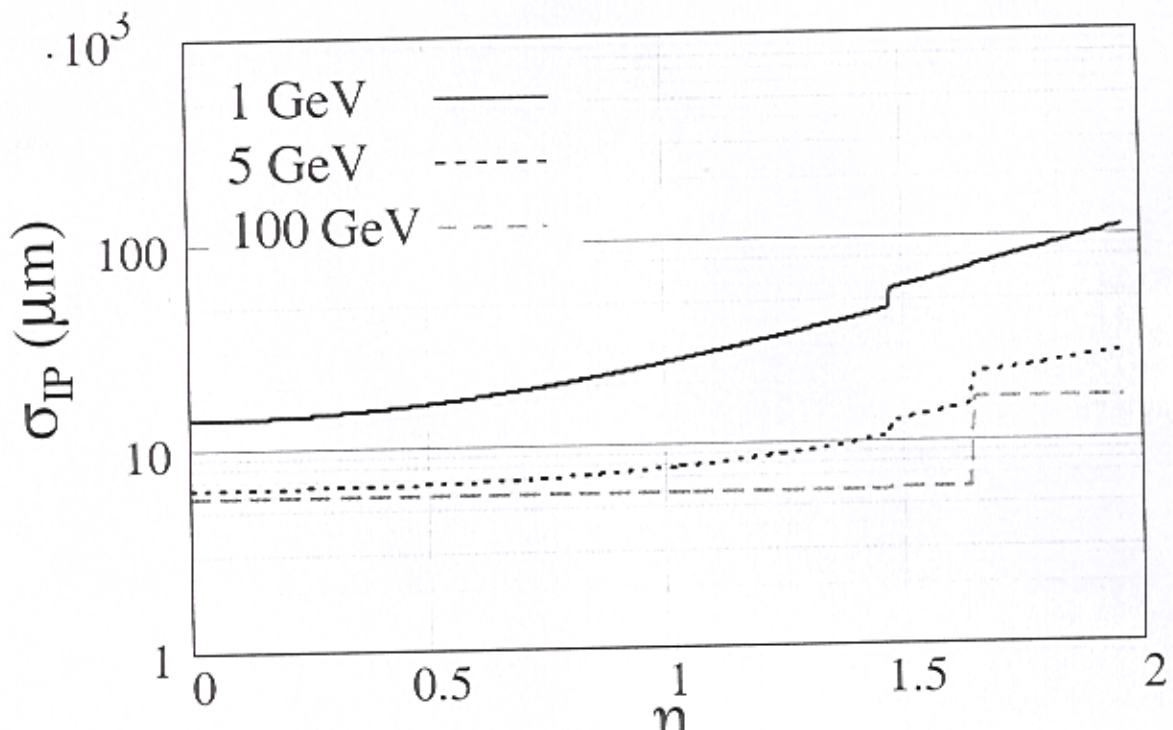
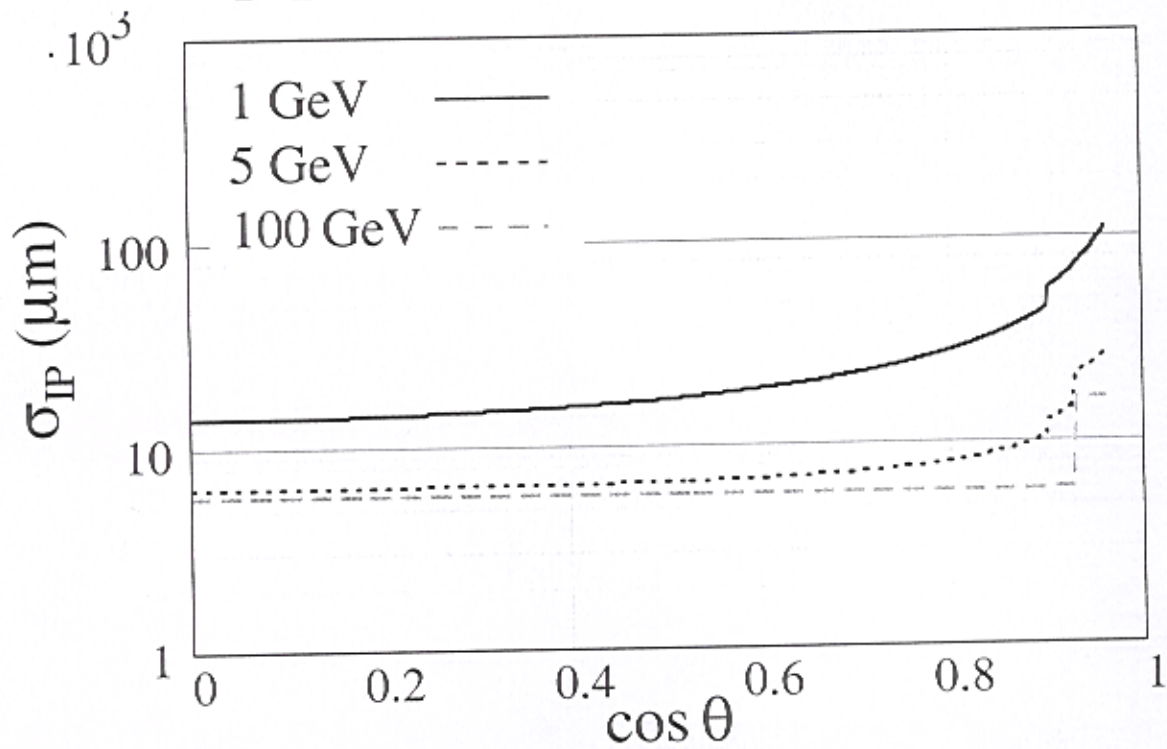
Impact parameter resolution

◆ Beam pipe radius 10 mm



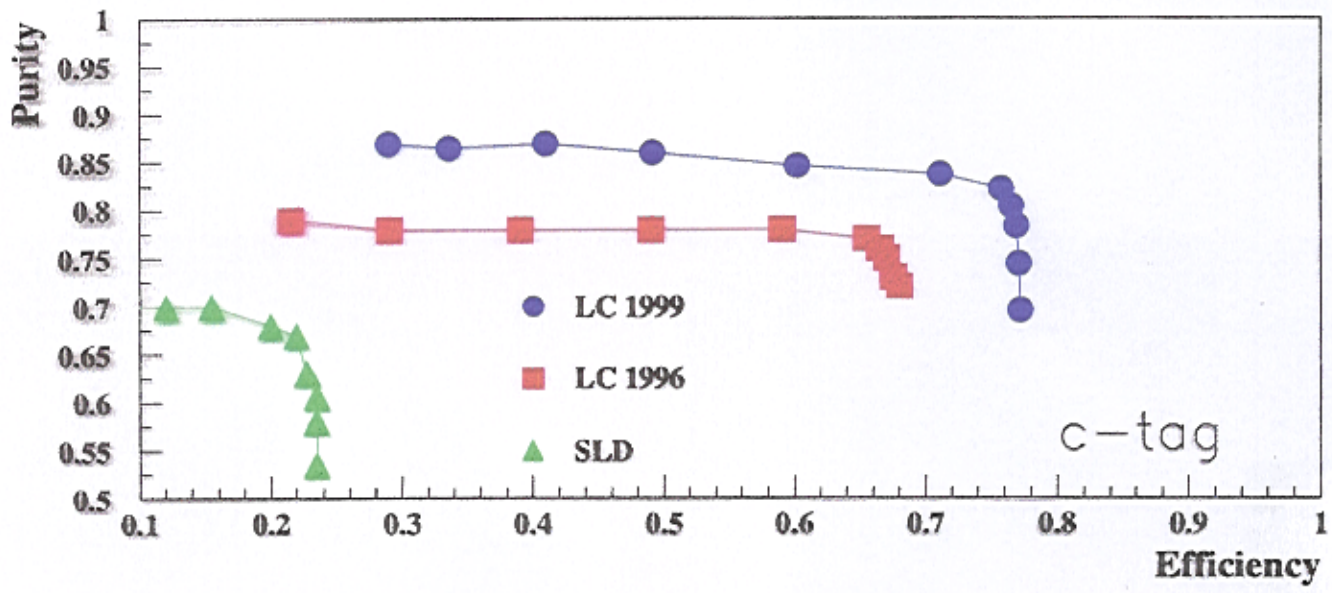
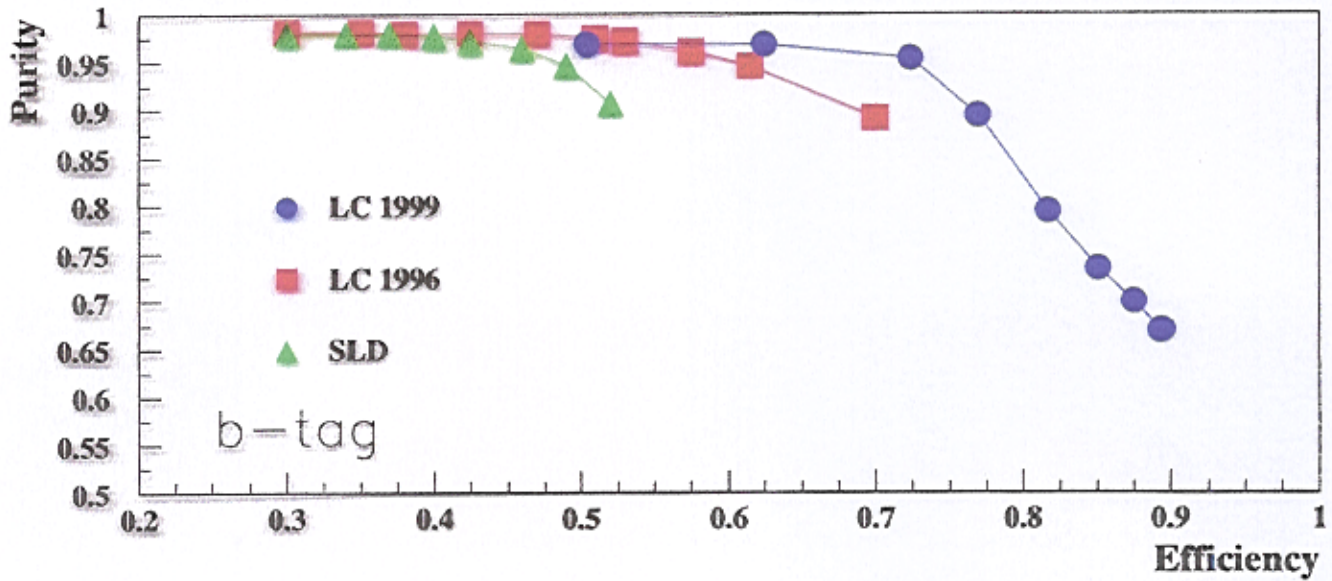
Impact parameter resolution

◆ Beam pipe radius 20 mm

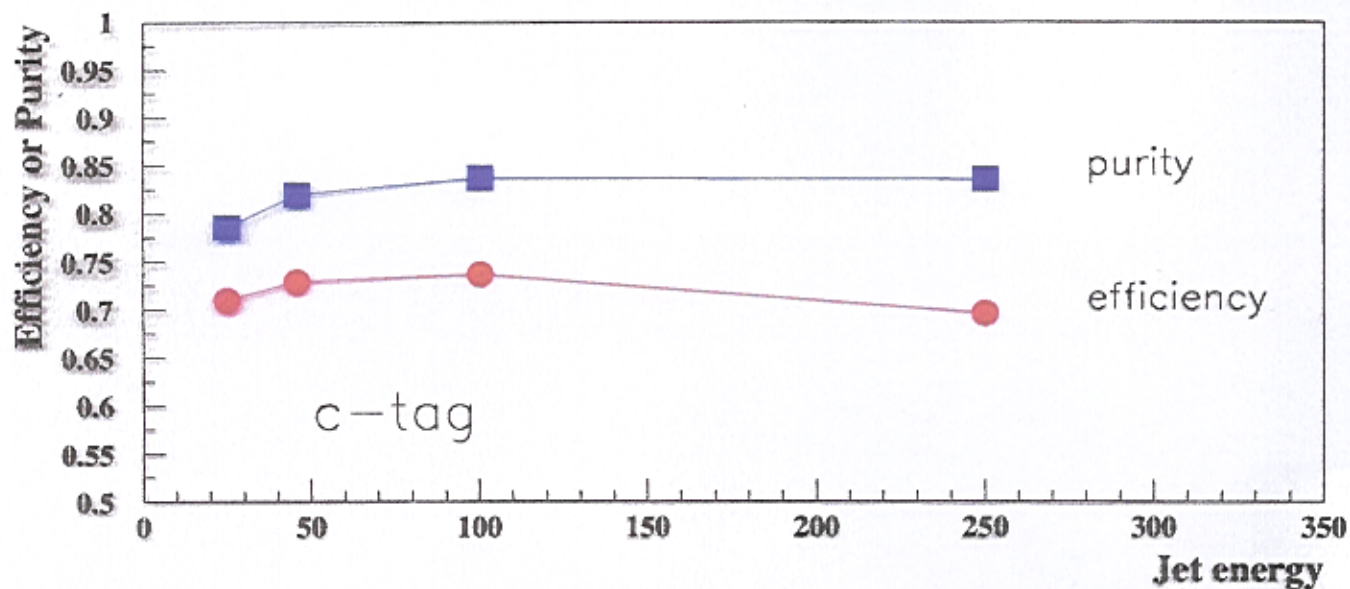
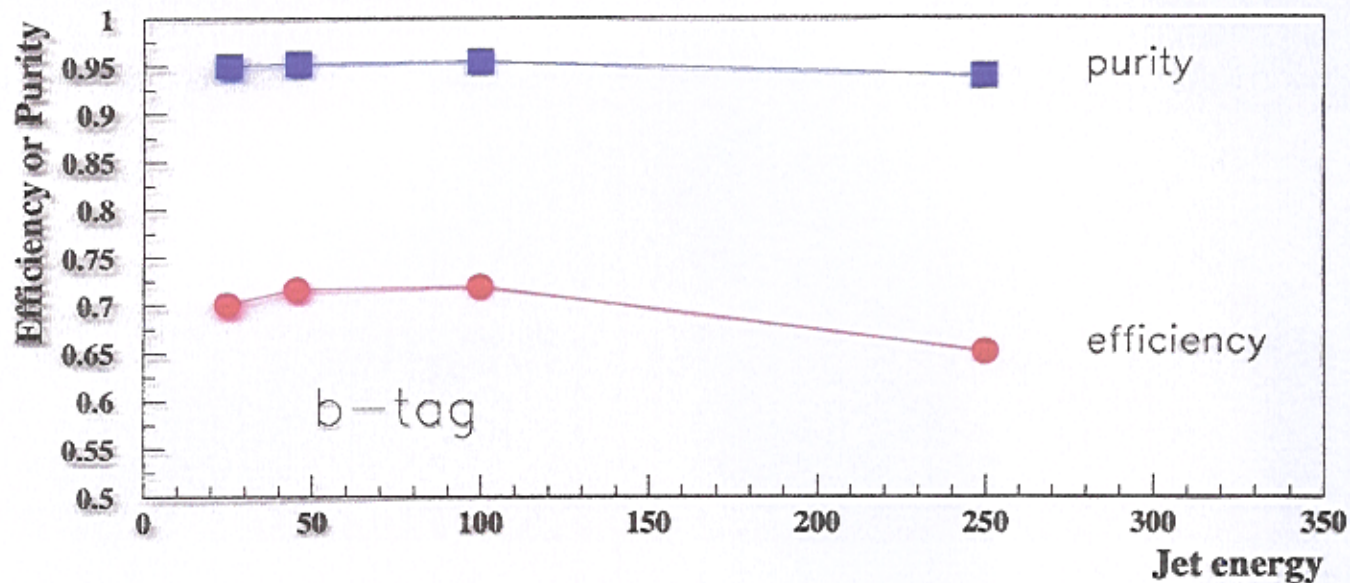


Using ZVTOP, $\cos \theta_{jet} < 0.71$:

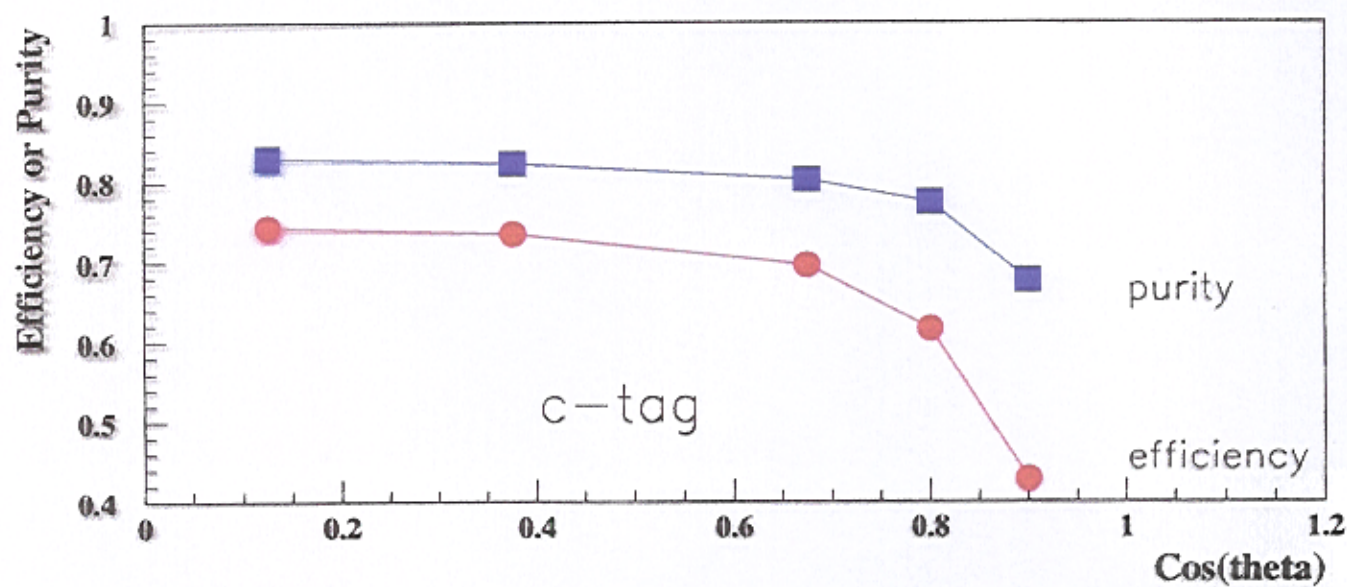
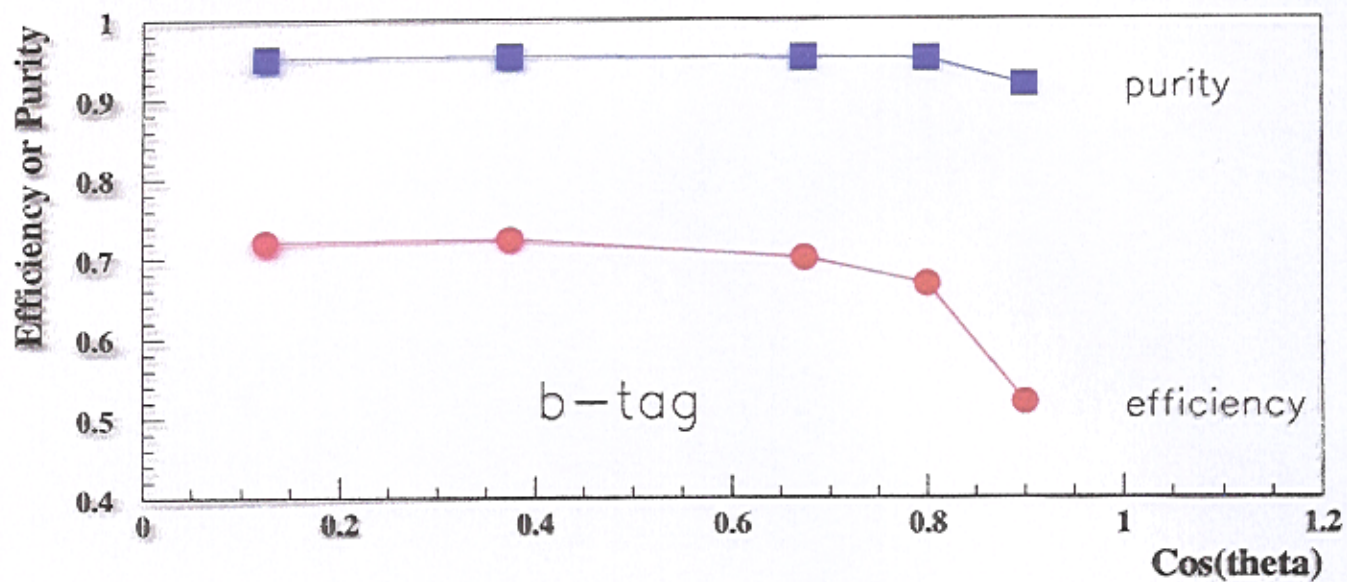
CCD VXD flavour tagging results: $E_{jet} = 46 \text{ GeV}$



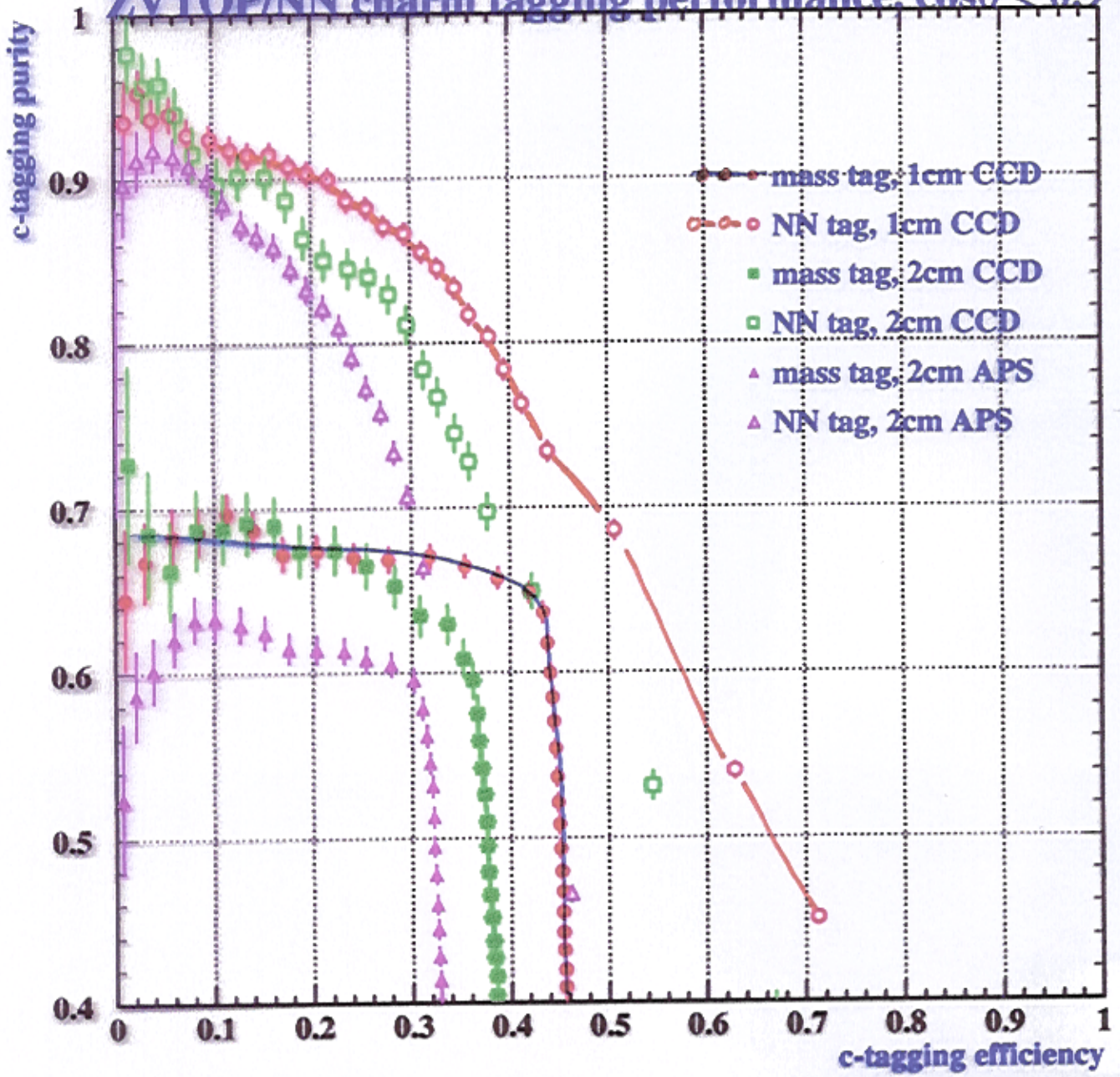
CCD VXD flavour tagging results: jet energy dependence



CCD VXD flavour tagging results: polar-angle dependence



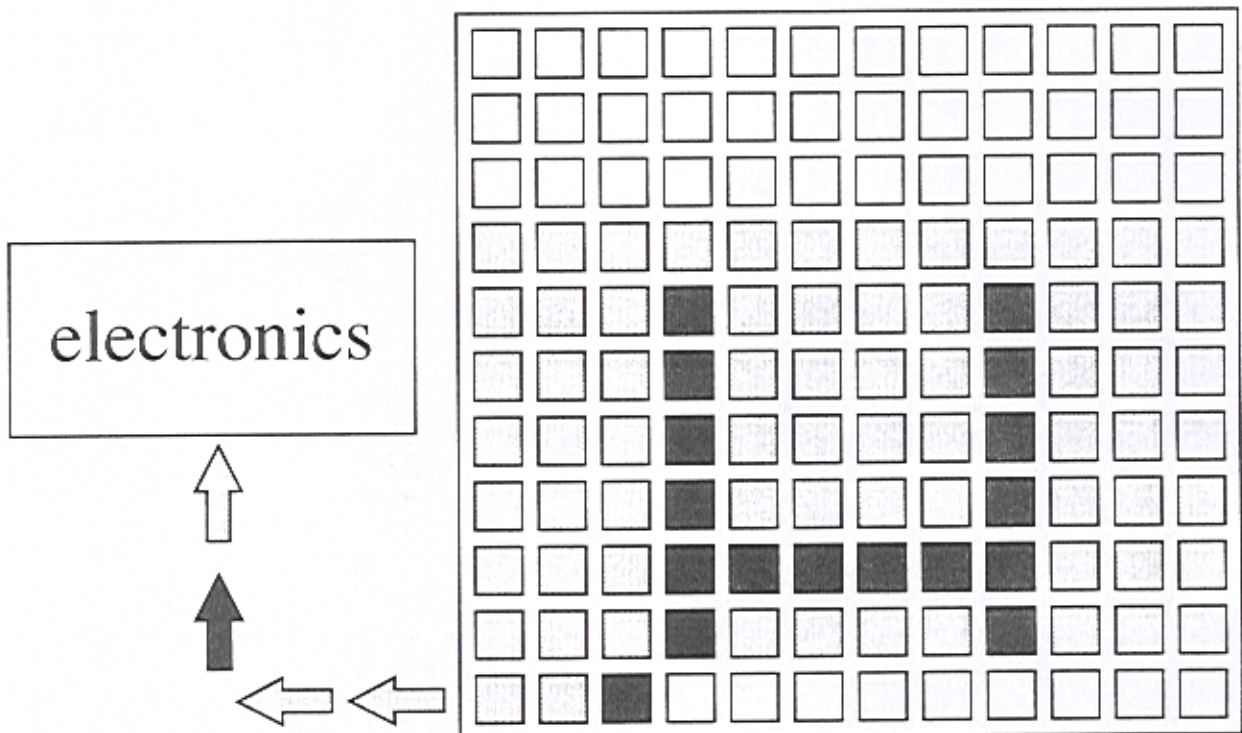
ZVTOP/NN charm tagging performance, $\cos\theta < 0.9$



Richard Hawkins

Problems due to TESLA environment

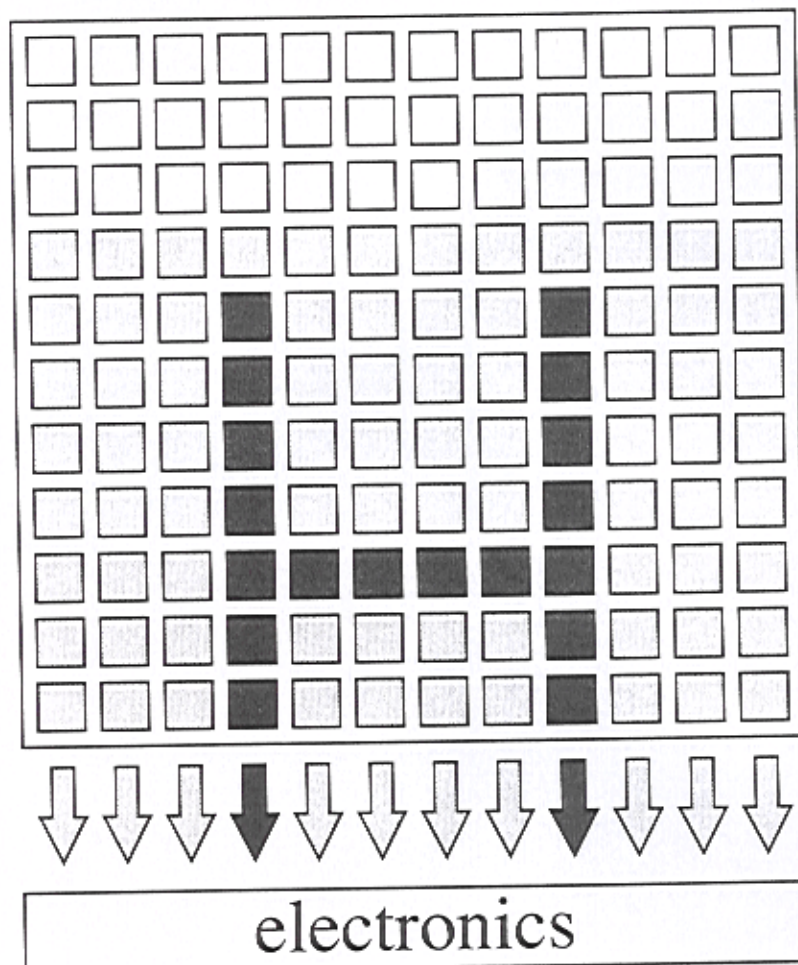
- ◆ Electron-positron pair induced hit density:
 - At 1 cm radius ~ 1 hit/mm² per B.C.
 - Keep occupancy at \sim few % level.
 - Need readout at ~ 25 GHz if “sequential”!



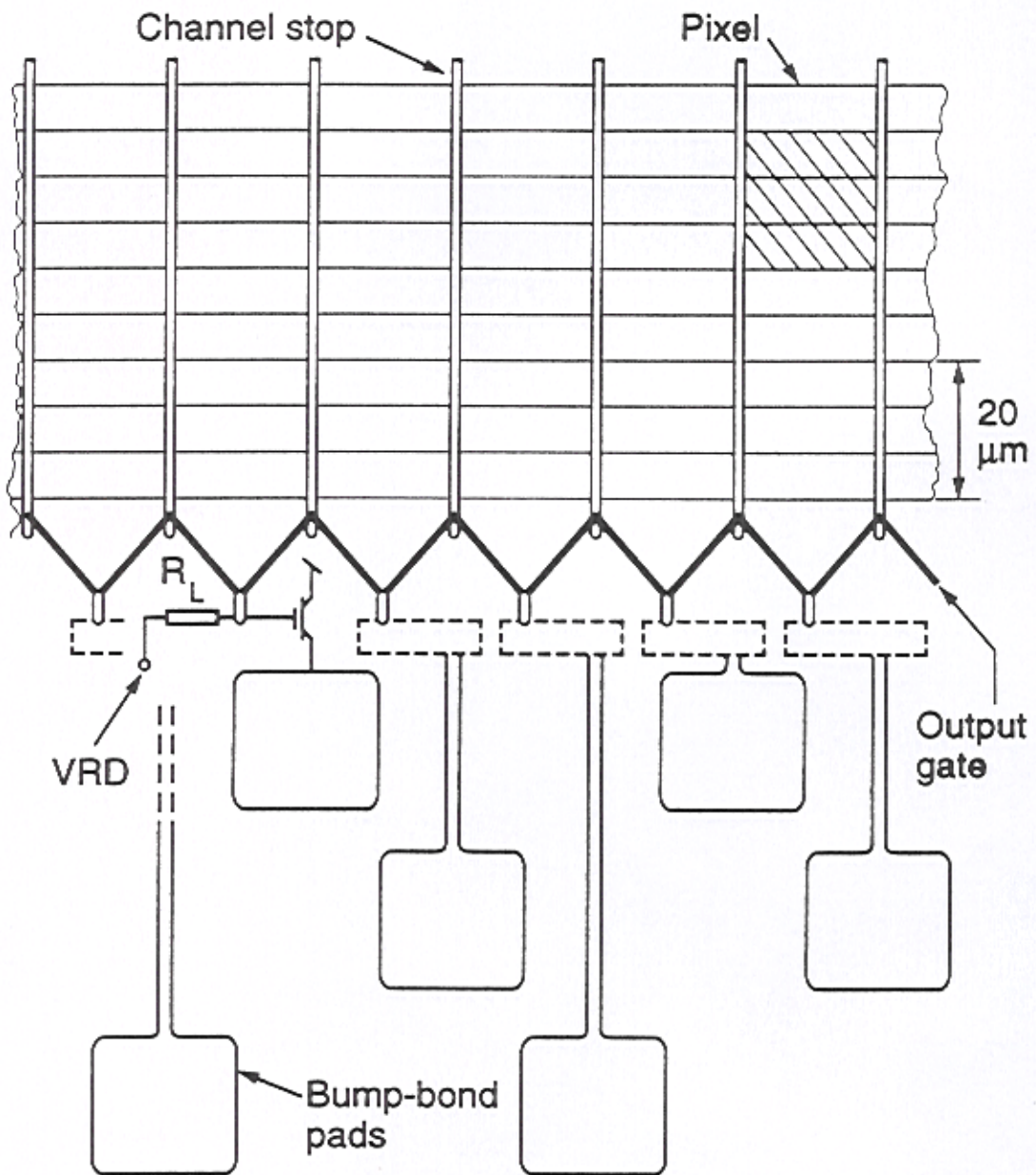
Problems due to TESLA environment cont.

◆ Solution:

- Column parallel readout.
- Necessary I register frequency now 50 MHz.

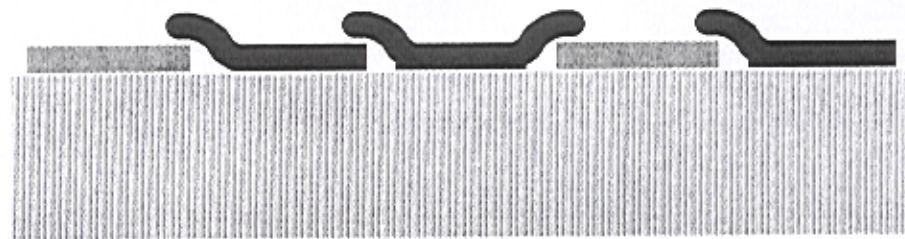
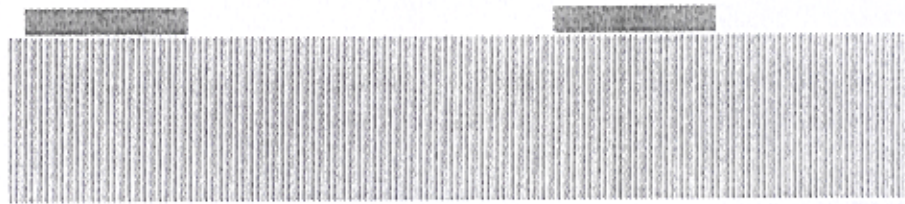


Column parallel readout



Increased readout frequency

- ◆ Work initiated on modifications to I gates. Now have:



- ◆ Aim for:



Readout frequency cont.

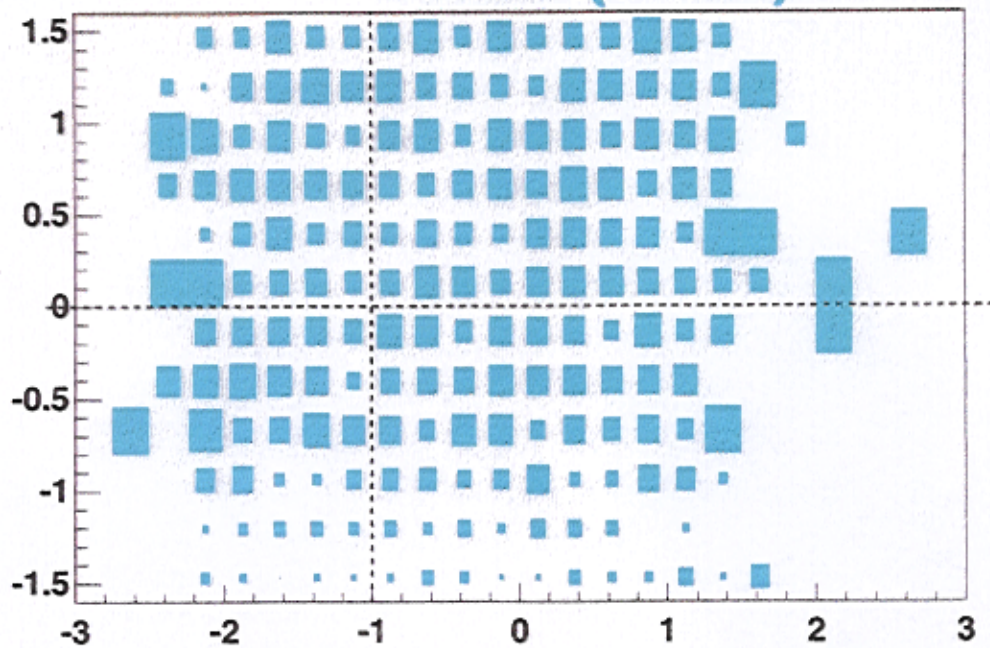
- ◆ Programme of simulations initiated.
- ◆ Cryostat and readout system under construction at RAL that will allow CCDs to be driven at these frequencies.
- ◆ Problems anticipated include additional power dissipation.
- ◆ Perhaps solve by combination of:
 - Liquid cooling of local electronics.
 - Reducing drive pulse voltages.
 - Exploiting TESLA duty cycle.

Radiation dose

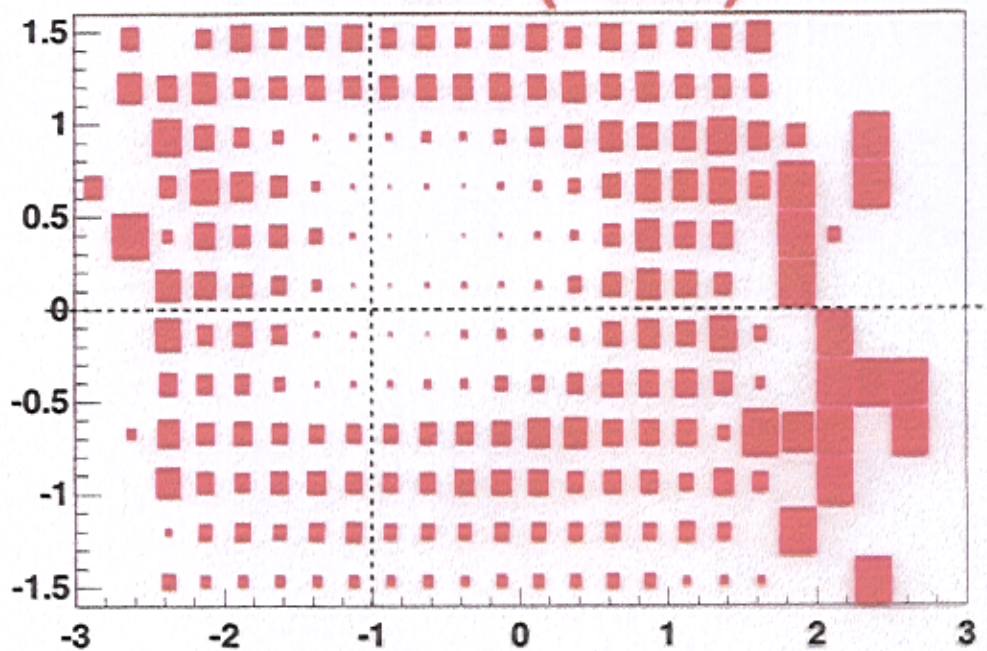
- ◆ Severe radiation damage due to dose of $\sim \text{few} \times 10^9$ (?) neutrons per cm^2 per year expected at TESLA?
- ◆ From recent proton studies, assuming NIEL conversion applies:
 8×10^9 1 MeV n/ $\text{cm}^2 \Rightarrow \text{CTI} = 5 \times 10^{-5}$.
- ◆ Nick Sinev: “ 20×10^9 1 MeV n/ cm^2 to produce CTI of 5×10^{-5} with no background charge”.
- ◆ Srour: “ 1500×10^9 1 MeV n/ cm^2 to get CTI of 5×10^{-5} with background charge and at $T = 140$ K”.
- ◆ Many ideas to increase radiation hardness:
 - Reduced charge storage volume.
 - Low T operation.

Efficiency for runs at at 90V

COLD (110K)



HOT (125K)



Paula Collins. RD39/DELPHI/LHCB/COMPASS.

Radiation dose cont.

- ◆ Test system for systematic study of radiation damage in CCDs under construction at Liverpool.
- ◆ CCD operation at temperatures down to 40 K to be examined.
- ◆ Optical (laser plus optical fibre) charge injection.
- ◆ Simultaneous “background” charge injection using radioactive source.

Summary

- ◆ Major problems that must be tackled in design and construction of CCD based vertex detector for TESLA:
- ◆ Readout speed:
 - Increase by factor 1000 using column parallel readout at 50 MHz.
 - Simulations starting.
 - Test rig under construction.
- ◆ Understand and reduce effects of radiation:
 - Study of effects of radiation on CCDs initiated.
 - Many ideas as to how radiation hardness can be improved.

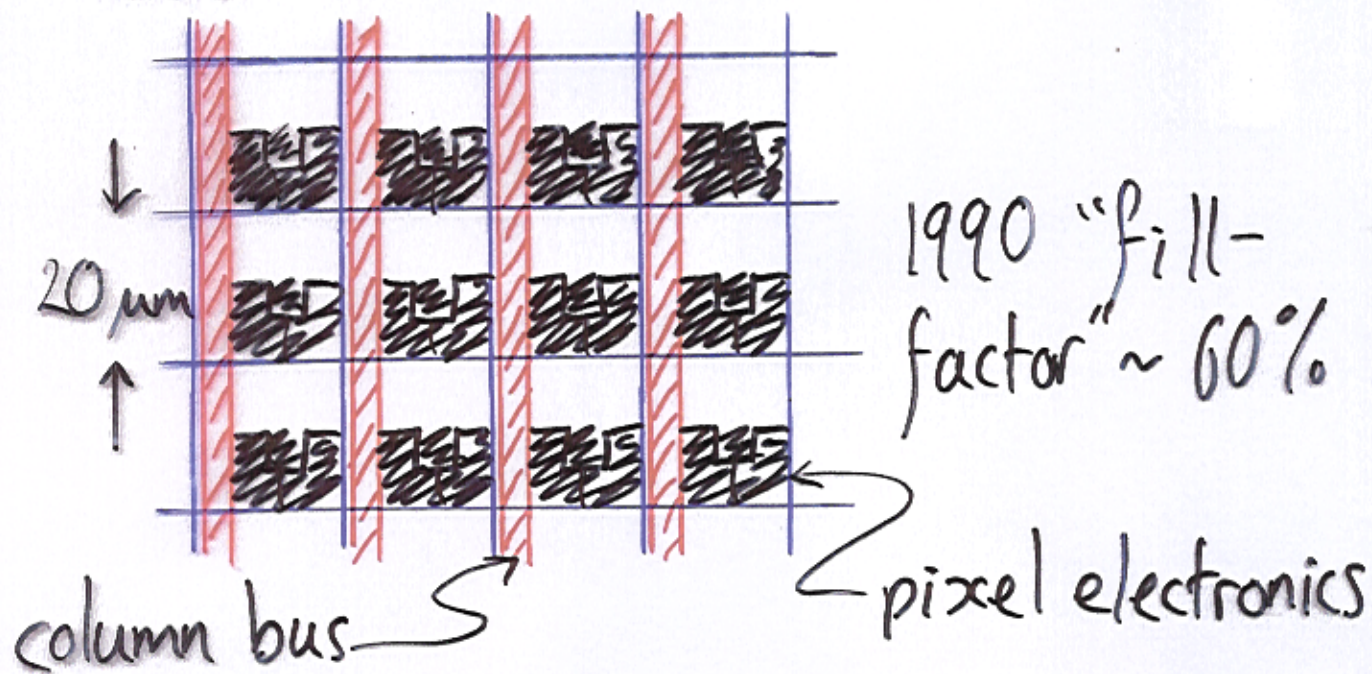
Summary cont.

- ◆ Mechanical stability:
 - Beryllium Ω and V beam structures plus gluing procedure being studied.
- ◆ Improve signal to noise ratio:
 - New readout circuit to be studied.
- ◆ If above can be solved, CCD based vertex detector powerful physics tool at TESLA.
- ◆ New directions:
 - Quark charge determination?
 - Vertex trigger?

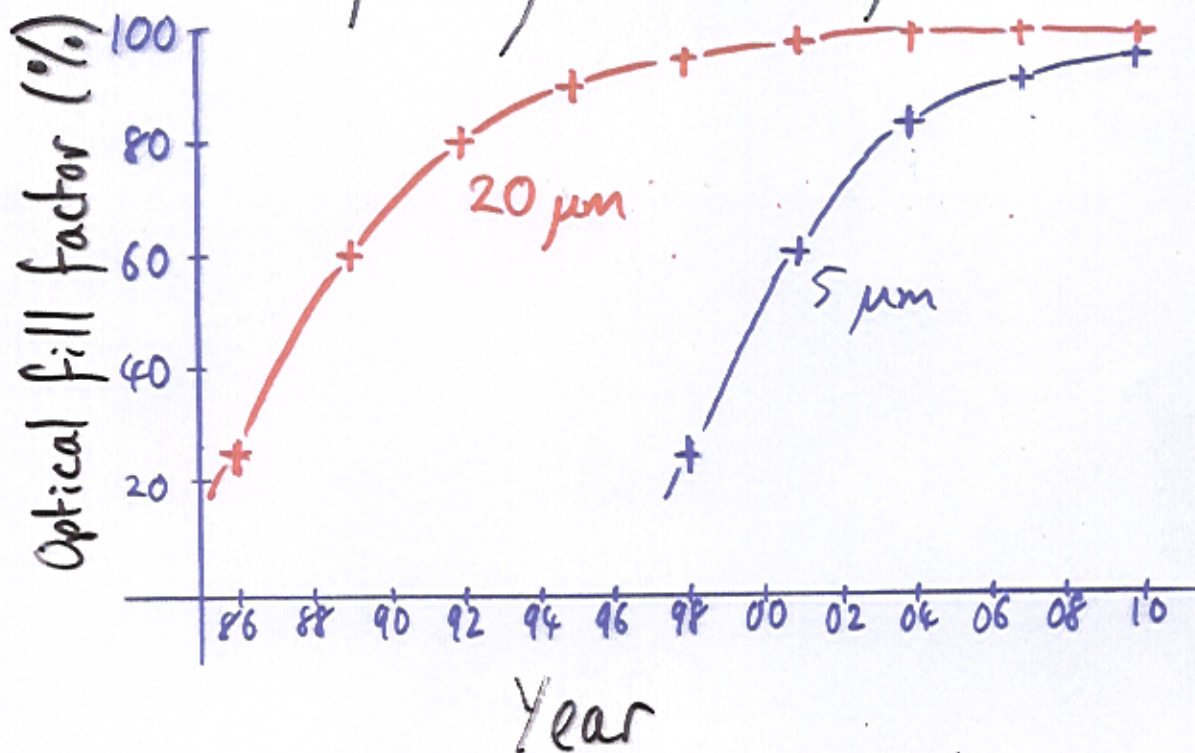
CMOS Vertex Detector

(Marc Winter, Renato Turchetta)

• Problem:



• But lithography improving!



CMOS Vertex Detector cont.

- Satisfactory fill factor for $20 \times 20 \mu\text{m}^2$ pixels by ~ 2000 ?
- Need "thicker than standard" epitaxial layer, diffusion, centroid finding for required σ_{pnt} .
- Problems with readout remain to be solved, c.f. CCD column parallel scheme.
- Advantage radiation hardness.
- Worth further study!